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## Piezoelectric Floating Element Shear Stress Sensor for the Wind Tunnel Flow Measurement

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### Abstract

A piezoelectric sensor with a floating element was developed for direct measurement of flow induced shear stress. The piezoelectric sensor was designed to detect the pure shear stress while suppressing the effect of normal stress generated from the vortex lift-up by applying opposite poling vectors to the piezoelectric elements. During the calibration stage, the prototyped sensor showed a high sensitivity to shear stress ( $91.3 \pm 2.1$  pC/Pa) due to the high piezoelectric coefficients ( $d_{31} = -1330$  pC/N) of the constituent  $0.67\text{Pb}(\text{Mg}_{1/3}\text{Nb}_{2/3})\text{O}_3$ - $0.33\text{PbTiO}_3$  (PMN-33%PT) single crystal. By contrast, the sensor showed almost no sensitivity to normal stress (less than 1.2 pC/Pa) because of the electromechanical symmetry of the sensing structure. The usable frequency range of the sensor is up to 800 Hz. In subsonic wind tunnel tests, an analytical model was proposed based on cantilever beam theory with an end-tip-mass for verifying the resonance frequency shift in static stress measurements. For dynamic stress measurements, the signal-to-noise ratio (SNR) and ambient vibration-filtered pure shear stress sensitivity were obtained through signal processing. The developed piezoelectric shear stress sensor was found to have an SNR of  $15.8 \pm 2.2$  dB and a sensitivity of  $56.5 \pm 4.6$  pC/Pa in the turbulent flow.

### 1. Introduction

The measurement of wall shear stress due to flow past solid surfaces provides important information about flow phenomena, including viscous drag, the transition to turbulence, and flow separation [1]. Therefore, the capability to measure both temporally and spatially resolved wall shear stress is important not only from the standpoint of research on basic fluid mechanics, but also from the perspective of flow control.

Techniques for measuring the shear stress can be categorized into indirect and direct methods [2]. In indirect methods, the shear stress is extracted from the measurement of other flow properties (e.g., pressure and wall temperature) that are related to the shear stress. For example, Pitot tubes such as the Preston tube or Stanton tube use a stream-based distribution of pressure along a flow channel to derive the shear stress [3]–[5]. The major disadvantage

of the Pitot tube method is that using the ports for pressure measurements requires modification to the wall, presenting a potential disturbance to the flow. Another common indirect method is the 'hot film technique' which is based on the thermal transfer principle [6]–[9]. Compared with Pitot tube measurement techniques, thermal sensors cause less disturbance to the flow because the sensor is mounted flush with the surface. However, they suffer from severe sources of error due to interference arising from surrounding humidity and temperature.

Considering the limitations of indirect methods, which strongly depend on empirical laws [2], direct methods are more accurate for measuring shear stress in complex, difficult-to-model flows [10]. Direct measurement relies on detecting the total amount of viscous drag that a surface-mounted force sensor experiences. An example of the direct measurement method is the floating element (FE) sensor, which is based on measuring the displacement of a FE that is flush with the flow. Capacitive [11]–[14] and piezoresistive [15], [16] techniques as well as surface acoustic wave (SAW) devices [17], [18] have been developed and used to measure the displacement of a FE. However, shear stress sensors fabricated by micro-machining have not yet received sufficient validation in a turbulent flow environment, so further advancement is needed to obtain reliable, high resolution shear stress measurements that are applicable to a wide range of flows.

This paper details a low cost small piezoelectric (PE) floating-element-type sensor ( $10 \times 10 \times 20 \text{ mm}^3$ ) that was developed using relatively facile techniques. A PMN-33%PT crystal was used in the sensor for its high PE coefficient ( $d_{31} = -1330 \text{ pC/N}$ ) [20], [21]. The proposed sensor was specifically designed to be both resilient against normal stresses that are generated from the vortex lift-up in the wind tunnel, and to prevent potential errors due to misalignments between the FE and the test plate. Finally, deflection of the PE sensing element was observed in wind tunnel testing. The static shear stress amplitude, that is the low frequency component of the shear stress, was determined through analytical modeling (cantilever beam theory) of the change in resonance frequency of the PE sensing element that would arise from deflection. The variation in charge output from the PE sensor was utilized to determine the dynamic shear stress in the turbulent flow condition.

In this paper, the sensor design and fabrication are described (Section 2). Experimental methods are presented and a dynamic calibration setup for the sensor and the wind tunnel model is illustrated in Section 3. Based on this experimental configuration, an analytical model for static stress is proposed and additional devices such as trip-strips and Pitot tubes are introduced for dynamic stress measurement. In section 4, results are presented, which include the characterization of the fabricated sensor and discussion of static and dynamic stress measurements. Finally, we conclude this paper with a brief summary in Section 5.

## 2. Sensor design and fabrication

The direct PE effect was used to sense the displacement of a FE for direct measurement of shear stress. As illustrated in Fig. 1, the FE shifts when flow shear force is applied. The displacement ( $\delta$ ) of the FE causes the bimorph PE structures to deflect, generating an electric charge through the transverse PE coupling (quantified by the coefficient,  $d_{31}$ ), of the

PE plates. The use of at least two parallel bimorphs allows the displaced, FE to move parallel to the fixed armature, preventing any rotation of the sensing armature that could disrupt the flow.

Under a shear stress load, the PE bimorphs bend as shown in Fig. 2. A shear stress is converted into a double-flexion deformation of the bimorphs. The tension and compression stresses are then distributed in the PE bimorph. The center of the bimorph corresponds to an inflection point where the stresses vanish. Due to the double-flexion strain caused by clamping, an alternative poling of each plate is necessary to prevent the electrical charge output from cancelling out. This method involves each PE plate being divided into two parts, in which the poling vectors  $P_1$  and  $P_2$  have opposite signs.

The measured displacement of the FE ( $2\delta$ ) and the charge output ( $Q$ ) can be used to calculate the shear stress and the sensitivity of the sensor, respectively, from the governing equation of the PE effect [19], [20], which is fully derived in a previous publication [21];

$$\begin{bmatrix} 2\delta \\ Q \end{bmatrix} = \begin{bmatrix} \frac{s_{11}^E L^3}{wh^3} & -\frac{3d_{31}L^2}{4h^2} \\ -\frac{3d_{31}L^2}{4h^2} & \frac{Lw}{h} \left( \epsilon_{33}^T - \frac{d_{31}^2}{4s_{11}^E} \right) \end{bmatrix} \begin{bmatrix} F \\ V \end{bmatrix} \quad (1)$$

where  $s_{11}^E$  is the elastic compliance at a constant electric field,  $w$ ,  $h$  and  $L$  are the width, height and length of bimorph structure, and  $d_{31}$  and  $\epsilon_{33}^T$  are the PE and dielectric constants, respectively.  $V$  is the voltage and  $F$  is the shear force accumulated from the shear stress distributed on the surface of FE, which can be calculated using the measured displacement of the FE based on Eq. (1).

The FE sensor was fabricated to be small in size ( $10 \times 10 \times 20 \text{ mm}^3$ ). The detailed fabrication procedure is presented in Fig. 3. Gold electrodes were deposited on the PMN-33%PT before it was diced ( $16 \times 2.5 \text{ mm}^2$ ). Gaps were formed in the middle of the electrodes to apply opposite poling vectors to the underlying plates. The poled plates were bonded as series mode bimorphs using an epoxy resin (Epotek 301), which ensured the higher sensitivity of the sensors in comparison with the parallel mode connection [19].

The final prototype of the sensor consists of the floating element (top), the clamped element (bottom) with an aluminum plate, two bimorph plates of PMN-33%PT crystals in a series combination, and a protective housing (Fig. 4).

Another important consideration taken into account during the design of the FE type sensors was the presence of errors caused by sensor misalignments. Misalignment errors originate from the geometry of the FE and the gap surrounding it. When the element is misaligned, pressures acting on the lip and surface of the element create moments which erroneously become part of the wall shear measurement [22]. Some comprehensive studies on misalignment error have been conducted by Allen *et al.* [23], [24] in which they state that while a perfectly aligned FE would have minimal error, optimizing different geometric

parameters could effectively reduce the errors caused by misalignment. They identified three key geometric parameters: misalignment (Z), gap size (G), and lip size (L). These parameters are illustrated in Fig. 5. To prevent or/and minimize likely errors from the misalignment between the FE and the test plate, several design considerations were taken into account for the sensors generated in this work. [22]–[25].

- The protective housing: A protective collar component surrounding the FE, if carefully aligned with the FE, can significantly mitigate the effects associated with the sensor misalignment (Z) during a facility installation.
- Gap size (G) between the FE and housing (200  $\mu\text{m}$ ): A sensor with a small gap size is much more prone to misalignment error. The optimum ratio of gap (G) to length of FE was found to be 0.02 through the experimental validation.
- Lip size (L) of the FE: This was intentionally minimized (1 mm) based on the total height of the FE (3 mm) to reduce the area on which the pressures had to act in the case of misalignment.

### 3. Experimental methods

#### 3.1. Dynamic calibration

A calibration setup was assembled to characterize the fabricated sensor. Fig. 6(a) represents the experimental setup for the dynamic calibration of the sensor. The actuator, excited by a function generator (Tektronix, Cary, NC) and power amplifier (ValueTronics, Elgin, IL), applied a low frequency (1 Hz) vibrational displacement to the sensor. A laser vibrometer (Polytec, Mooresville, NC) was used to measure the displacement of the FE, while an oscilloscope (Agilent Technologies, Santa Clara, CA) provided a visual display of the displacement profile. The charge output generated from the bimorph PE plate was measured by the lock-in amplifier (Stanford Research Systems, Sunnyvale, CA). In this test, the reference frequency (1 Hz) of the lock-in amplifier was synchronized with the function generator and the excitation force, i.e., displacement magnitude, was controlled by increasing the voltage amplitude from the function generator in the range of 0.1 V to 1.0 V with a 0.1 V sub-step.

The dynamic calibrations of the shear stress and normal stress were conducted by positioning the contact probe of the actuator on the side and top of the FE, respectively. (Fig. 6(b), (c)).

Usable frequency range of the sensor was measured by increasing the reference frequency of the function generator by 1 Hz up to the phase shift of the sensor.

#### 3.2. Wind tunnel model

The characterization of the PE sensors under actual wind-flow conditions was carried out in a subsonic wind tunnel facility at North Carolina State University (NCSU). The facility enabled an evaluation of the response from PE sensors by comparing the output signals with aerodynamic measurements from several traditional approaches.

The test apparatus was a flat plate fabricated from medium density fiberboard (MDF). The flat plate was 406 mm (16") in chord, 813 mm (32") in span and 19.5 mm (3/4") thick. A semi-circular leading edge was attached to the front edge of the flat plate, and the PE sensor housing was positioned 229 mm (9", 0.56 chord) from the leading-edge of the flat plate. Additionally, the flat-plate model had an extended trailing flap attachment. This movable flap enabled adjustments in overall pressure distribution over the flat plate, ensuring that the stagnation point was positioned on the upper surface of the flat plate. Fig. 7 represents the wind tunnel experimental setup for sensors, in which the PE sensor was flush-mounted on the flat plate and carefully aligned by adjustable joint bolts. Fig. 8 shows the schematic of the setup for the PE sensor that was mounted on the test apparatus. Qualitative estimates of the skin friction coefficient and the expected shear stress on the flat plate were conducted using theoretical and experimental boundary layer analysis with the Pitot tube apparatus, which will be introduced in Section 3.4 in detail.

### 3.3. Modeling for static stress measurement

In limited freestream velocity ranges ( $V < 35$  m/s, laminar flow region), the charge output of the PE sensor disappeared after a period of time. Signal vanishing is not appropriate for static stress measurements, so an alternative method that could detect the static stress with the PE sensor was used.

An impedance analyzer (Agilent 4294A, Agilent Technologies Inc., Santa Clara, CA) was used to measure the variations of resonance frequency due to the deformation of the beam from shear stress. First, lateral mode resonance ( $f_r$ ) and anti-resonance ( $f_a$ ) frequency were the focused ranges, since the deflection of bimorph plates leads to a change of length in bimorph plates. To analyze resonance frequency shift results using electromechanical modeling, we adopted the cantilever beam theory [26] since the PE bimorph sensor is analogous to a cantilever beam with the same boundary conditions and structures. The central concept of this model is that the shear stress applied to the FE (tip mass) accelerates the tip mass of the beam, which decreases the resonance frequency of the beam (Fig. 9).

For a cantilever beam subjected to free vibration, the system is considered to be continuous with the beam mass distributed along the shaft. The equation of motion for this can be written as [26]:

$$\frac{d^2}{dx^2} \left\{ EI(x) \frac{d^2 y(x)}{dx^2} \right\} = \omega^2 m(x) y(x) \quad (2)$$

where  $E$  is the Young's modulus of the beam material,  $I$  is the moment of inertia in the beam cross-section,  $m$  is the mass per unit length,  $m = \rho A$ ,  $\rho$  is the material density,  $A$  is the cross-sectional area,  $x$  is the distance measured from the fixed end,  $y(x)$  is displacement in  $y$  direction at distance  $x$  from fixed end, and  $\omega$  is the angular natural frequency. Boundary conditions of the cantilever beam are:

$$y(0) = 0, y'(0) = 0, y''(L) = 0, y'''(L) = 0 \quad (3)$$

For a uniform beam under free vibration from Eq. (4), we get:

$$\frac{d^4 y(x)}{dx^4} - \beta^4 y(x) = 0, \quad \beta^4 = \frac{\omega^2 m}{EI} \quad (4)$$

The mode shapes for a continuous cantilever beam are given as:

$$y_n(x) = A_n \{ (\sin \beta_n L - \sinh \beta_n L)(\sin \beta_n x - \sinh \beta_n x) + (\cos \beta_n L - \cosh \beta_n L)(\cos \beta_n x - \cosh \beta_n x) \}, \quad (5)$$

$$n = 1, 2, 3, \dots, \infty$$

From Eq. (5), a closed form of the resonance frequency  $f_n$ , and the effective mass of beam  $m_{eff}$ , without any tip mass can be written as:

$$f_n = \frac{1.875^2}{2\pi} \sqrt{\frac{EI}{mL^4}} = \frac{1.875^2}{2\pi} \sqrt{\frac{EI}{\rho AL^4}} = \frac{1}{2\pi} \sqrt{\frac{k}{m_{eff}}} \quad (6)$$

$$m_{eff} = \frac{k}{(2\pi \cdot f_n)^2} = 0.2427 m_{beam} \quad (7)$$

Lastly, by adding together the tip mass ( $m_{tip}$ ), the mass of the FE ( $m_{float}$ ), and the effective mass of the beam ( $m_{eff}$ ), the total beam mass ( $m_{total}$ ) was calculated, and the first flexural mode resonance frequency,  $f_{n'}$ , in the case of accelerated tip mass was derived:

$$m_{total} = m_{eff} + m_{float} + m_{tip} = 0.2427 m_{beam} + m_{float} + m_{tip} \quad (8)$$

$$f_{n'} = \frac{1}{2\pi} \sqrt{\frac{3EI}{(0.2427 m_{beam} + m_{float} + m_{tip}) L^3}} \quad (9)$$

Next, the applied shear stress on the FE was converted to the accelerated tip mass by using the calibration results and the equation of cantilever beam theory to calculate tip displacement,  $\delta_{tip}$ :

$$\delta_{tip} = \frac{FL^3}{12EI} = \frac{m_{tip} g L^3}{12EI} \quad (10)$$

where,  $g$  is the acceleration of the tip mass. The previous calibration results were used to verify the relationship between the shear stress and deflection of beam. Then the accelerated tip mass was determined using cantilever beam theory. Finite element analysis (FEA) was also performed to verify the resonance frequency shift of the cantilever beam using the commercial FEM package ANSYS®.

### 3.4. Dynamic stress measurement

The dynamic stress measurement was performed under turbulent conditions in the wind tunnel. To ensure a turbulent boundary layer at the sensor location, trip-strips were used at a distance in front of the sensor to force the transition to turbulent flow (Fig. 10 (a)) [27].

A charge amplifier (output rate, 0.316 mV/pC) and an oscilloscope (20 s window range) were used to ascertain the contributions to the output signal from wind tunnel vibrations, the sensor surface was covered to remove PE floating element displacement arising from shear stress. The resultant signal was filtered out from the signal obtained when the PE floating element was exposed to the airflow to isolate the shear stress-induced signal.

Simultaneously, a boundary layer analysis with Pitot tubes was conducted to obtain reference shear stress data, and was used for comparing theoretical and experimental values. An experimental setup on the flat plate, consisting of a commercial Pitot tube apparatus (Aerolab LLC, Jessup, MD) with a 10-tap total pressure probe, is presented in Fig. 10 (b). The probe was attached on the flat plate at the same distance from the leading edge as the PE sensor. The Pitot tube probes were 1.22 mm apart along the diagonal. Based on the Clauser method [28], [29], which is a common approach for estimating the wall shear stress in turbulent boundary layers, the friction velocity  $u_\tau \equiv \sqrt{\tau_w/\rho}$  can be calculated using the measured mean velocity profile  $U(y)$  in the logarithmic region of the boundary layer, given by;

$$\frac{U(y)}{u_\tau} = \frac{1}{\kappa} \ln\left(\frac{yu_\tau}{\nu}\right) + B \quad (11)$$

where,  $\kappa$  is the von Karman constant (0.41),  $\nu$  is the fluid kinematic viscosity, and B is the integral constant (5.0) [29]. The wall shear stress can be acquired from the calculated friction velocity with respect to various freestream velocities from 12 m/s to 28 m/s.

## 4. Results and discussions

### 4.1. Dynamic calibration

Fig. 11 shows the displacement ( $2\delta$ ) of the FE measured from the laser vibrometer as a function of various voltage amplitudes arising from the function generator which were converted into the shear stresses through the actuator based on Eq. (1),  $\tau_w = \frac{2\delta \cdot wh^3}{s_{11}^E L^3 \cdot A_{FE}}$ .

Calculated and measured electrical charge output for the shear and normal stresses are shown in Fig. 12. Measured electrical charge output generated by the shear stress shows an almost linear relationship with respect to the shear stress. Based on a linear fit,  $y = 91.29x - 43.7$ , the resolution of the sensor was determined to be approximately 0.5 Pa. The experimental shear stress sensitivity ( $91.3 \pm 2.1$  pC/Pa) was 10–12 % lower than calculated one ( $S_{cal} = \frac{Q}{P} = -\left(\frac{3d_{31}L^2}{4h^2}\right) \cdot A_{FE} = 102.1$  pC/Pa), which may be caused by inaccurate PE constants used in the calculation and the capacitance reduction due to the residual electrode

gaps in the PMN-33%PT plates. The high shear stress sensitivity was likely due to a high PE charge constant ( $d_{31} = -1330$  pC/N) of PMN-33%PT single crystal [20], [21] and the small thickness of bimorph plates ( $h = 0.5$  mm). The sensor yielded an almost-zero charge output under normal stress (about 1–1.3 % of the shear sensitivity), which was well aligned with the theoretical expectation that the normal stress-induced charge should be approximately zero due to the electromechanical symmetry of bimorph plates. The usable frequency range of the sensor was also determined to be  $\sim 800$  Hz (Fig. 13), which indicated that the sensor had a broad-band usage in the turbulent flow condition.

#### 4.2. Static stress measurement

In the static shear stress condition, Fig. 14 represents the variations of frequency as a function of flow velocity in both the flow and vibration existing condition and the vibration only condition. The resonance frequency shift rate is much higher in the flow and vibration condition ( $-1.1$  %) than in the vibration only condition ( $-0.3$  %) when compared at the condition of highest velocity (35 m/s).

Based on the analytical and simulated results of the cantilever beam model, a comparison of frequency shift rates with the experimental results is shown in Fig. 15. With the vibration effect filtered out, the experimental results showed a lower frequency shift rate than the analytical and simulated models (root-mean-square error of 13.7 %), which may come from damping that occurs in the real device that is not included in the models. However, the results demonstrated consistency between the two frequency shift rates in the overall trend.

#### 4.3. Dynamic stress measurement

The result of the boundary layer analysis utilizing data collected from the Pitot tube device is shown in Fig. 16. A non-linear curve fitting with the Boltzmann model was conducted on the measured data in which the adjusted R-squared value is 0.9936. Furthermore, the result of a fitted line supports the theoretical shear stress curve which is calculated using the  $1/7$  power-law [30].

Based on the dynamic stress experimental setup, the shear stress effect on the sensor was verified under turbulent flow conditions by comparing the peak-to-peak charge outputs of condition #1 (flow + vibration) and condition #2 (vibration only). As the freestream velocity increased, peak-to-peak charge outputs at both conditions also increased. However, higher peak-to-peak charge outputs were observed under condition #1 relative to condition #2, which indicated that the sensor was able to detect the dynamic shear stress, albeit convolved with signals arising from wind tunnel vibrations (Fig. 17).

To deconvolute the dynamic shear stress from the vibrational contributions, 5 data sets were used for each air speed condition with a time window as 20 s. The root-mean-square (RMS) charge output was determined for each condition. Fig. 18 shows the differences in RMS charge output between cases, which indicated that the PE sensor could detect dynamic shear stress. Considering the vibration only induced sensor's sensitivity as the noise signal, the signal-to-noise ratio (SNR) can be calculated as  $15.8 \pm 2.2$  dB, which indicates the competitive performance of the sensors.



To get the pure shear stress data, we filtered out the vibration induced noise by subtracting the vibration charge outputs, which is shown in Fig. 19.

Compared with dynamic calibration data, wind tunnel test data exhibited lower charge outputs, approximately 20 to 27 %, than those obtained in the calibration experiments. This suggests that the wind tunnel vibrational contribution to the signal may reduce the sensitivity of the sensor. The frequency spectrum of vibration in the sensor higher than 800 Hz may cause the sensor performance to degrade. However, sensitivity of the sensor remains high ( $56.5 \pm 4.6$  pC/Pa), and when considering various uncontrollable parameters in the wind tunnel, such as temperature and vibration, it presented comparable results.

## 5. Conclusion

In this work, a PE floating element type shear stress sensor was developed, calibrated and tested in a wind tunnel. The sensor was designed to minimize misalignment error by using a protective housing, optimizing the gap size, and minimizing the lip size. The sensor was also designed to be resilient against normal stresses generated from the vortex lift-up so that pure shear stress could be measured. The calibration results showed that the sensor yielded high shear stress sensitivity due to the high PE charge constant ( $d_{31}$ ) of the PMN-33%PT single crystal and small thickness of the plates, while showing minimal sensitivity to normal stress. In subsonic wind tunnel tests, electromechanical modeling was performed based on the cantilever beam theory for verifying the results of the resonance frequency shift in the static stress condition. The sensor was found to have an SNR of  $15.8 \pm 2.2$  dB and a high sensitivity of  $56.5 \pm 4.6$  pC/Pa in the turbulent flow.

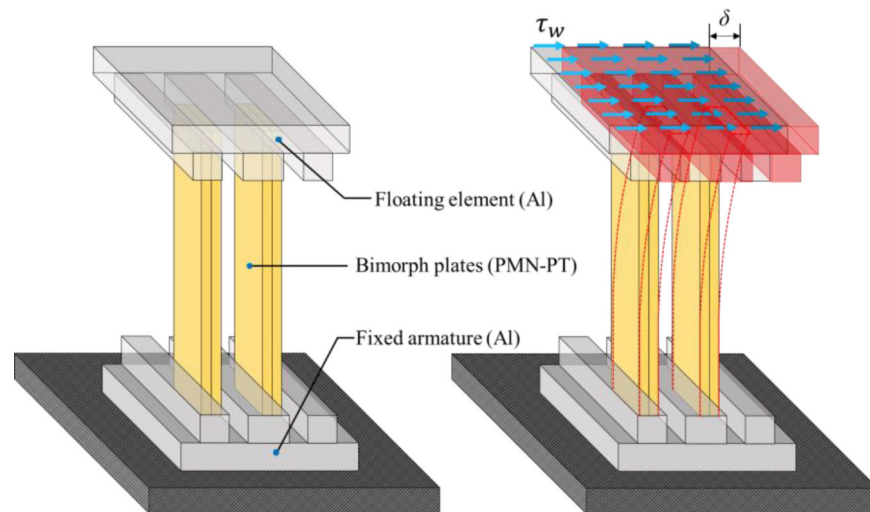
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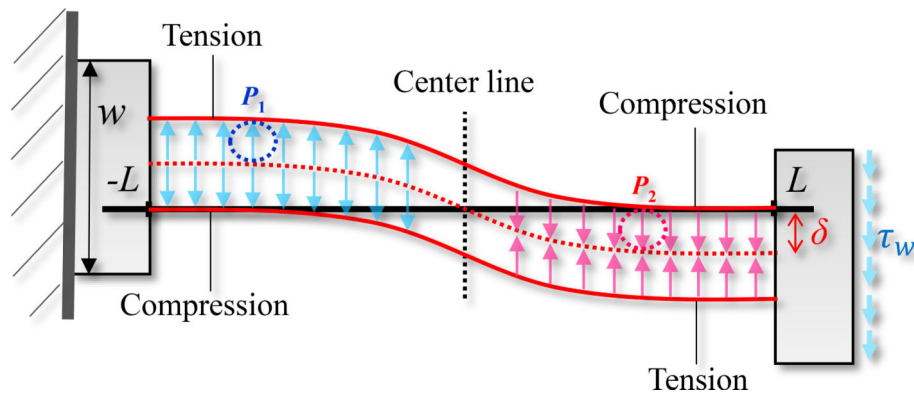
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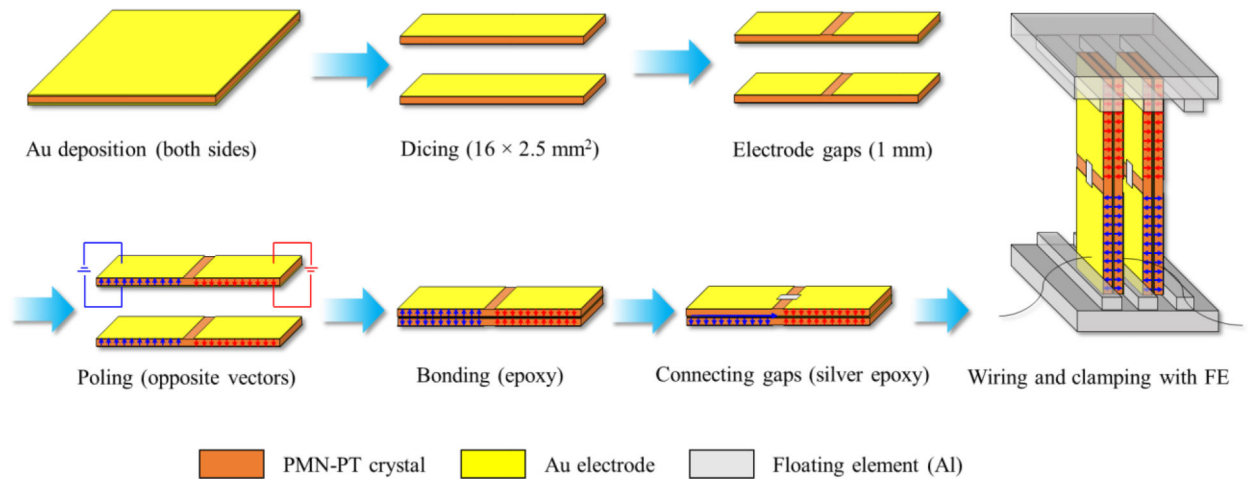
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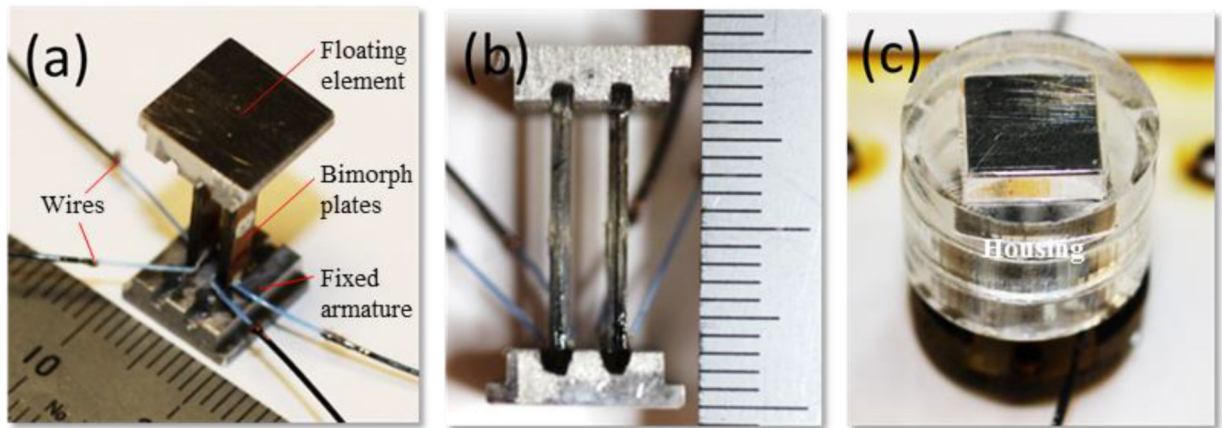
**Figure 1.**  
 Schematic of FE sensor, (left) no displacement of FE in the no flow condition (right) displacement of FE in the application of shear stress



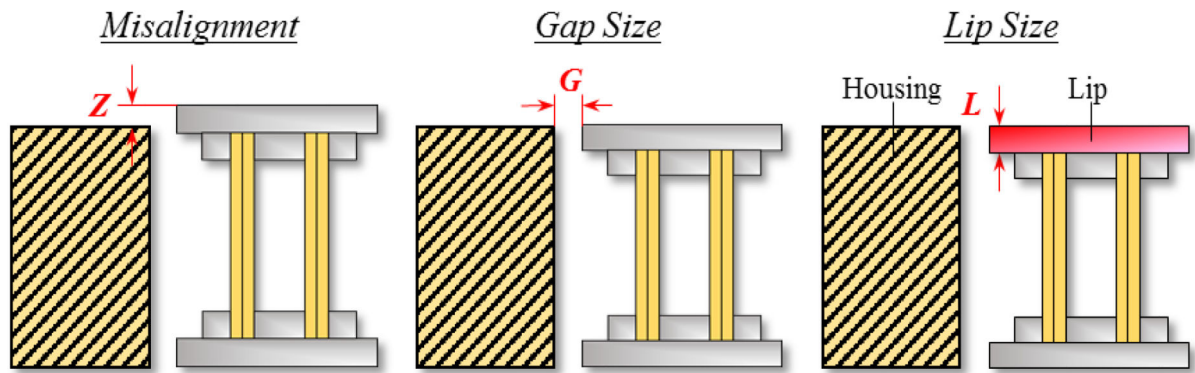
**Figure 2.**  
Configuration of deflected bimorph structure



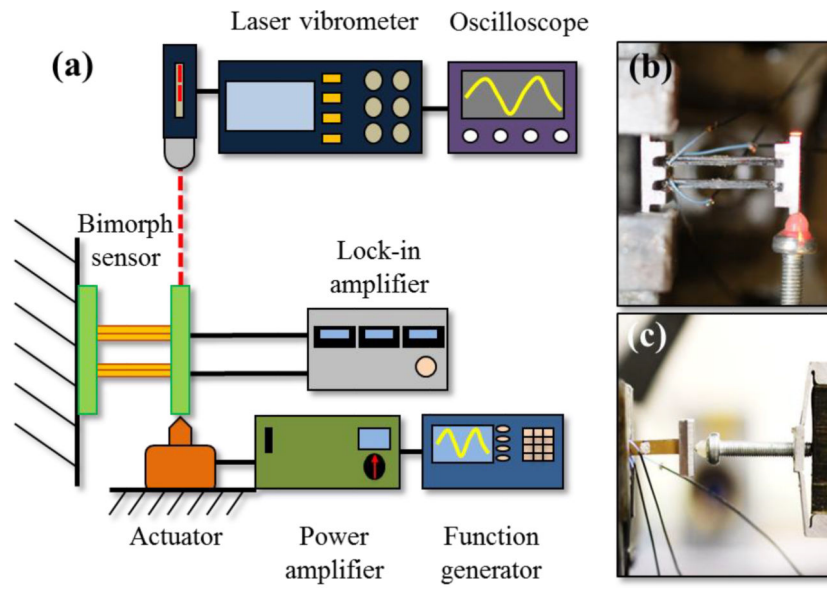
**Figure 3.**  
Sensor fabrication procedure



**Figure 4.** Configuration of PE sensor (a) isometric (b) front view (c) with housing. Demarcation on the ruler included in images (a) and (b) are mm.

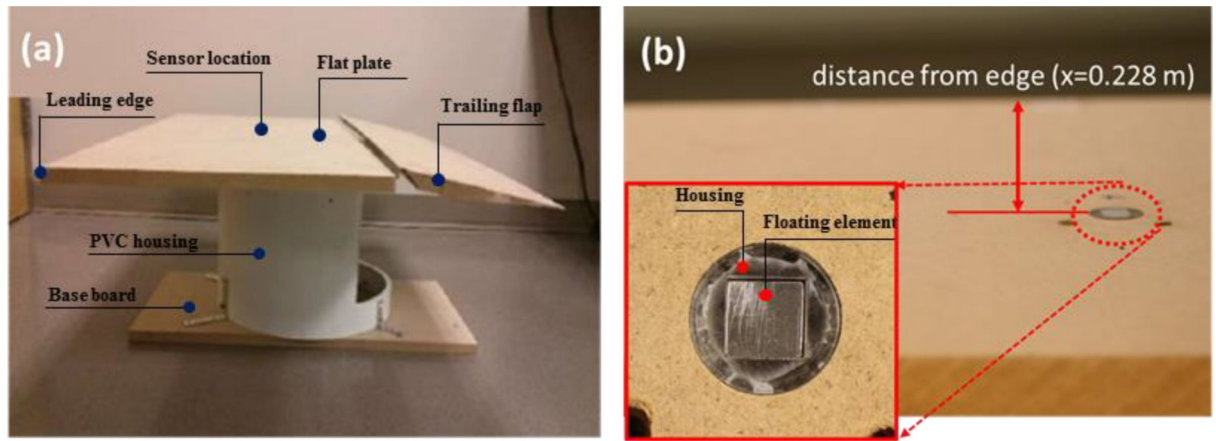


**Figure 5.**  
Key parameters of the FE to minimize the potential errors

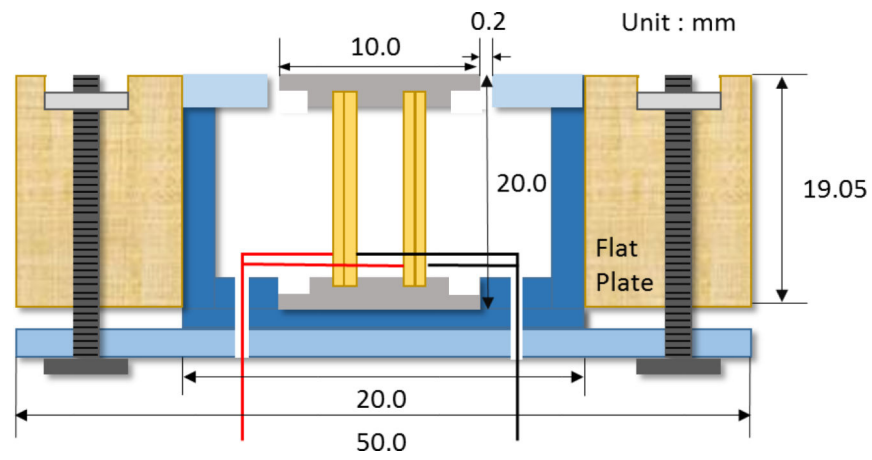


**Figure 6.** Experimental setup for the calibration of a sensor in (a) overall view, (b) shear stress, (c) normal stress

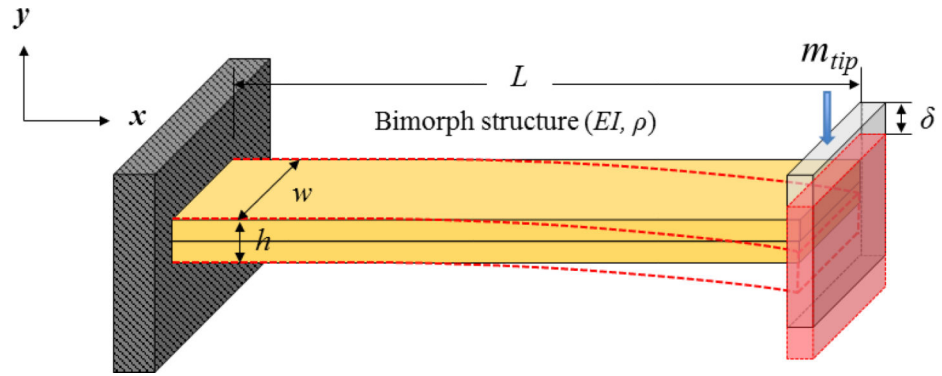




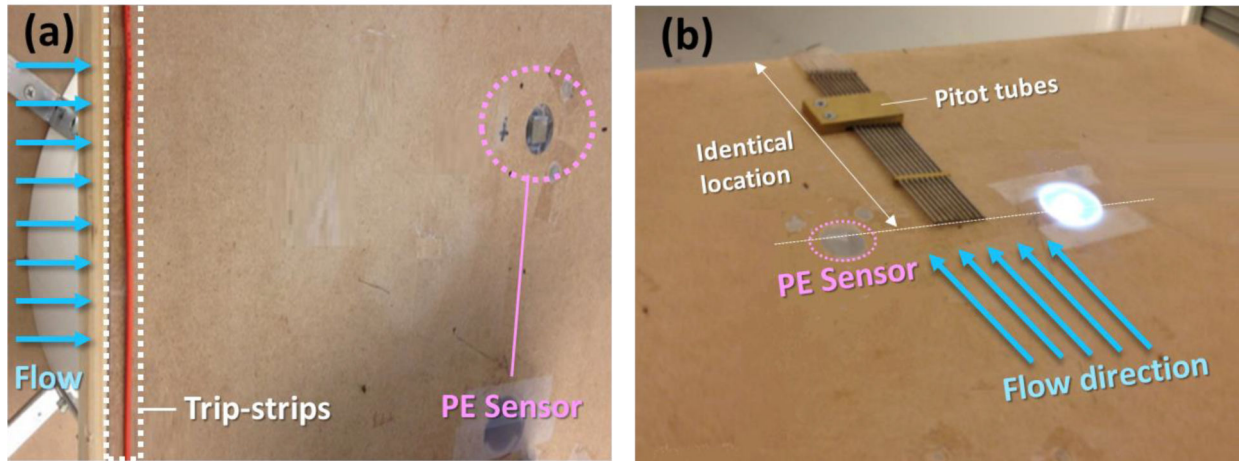
**Figure 7.**  
Wind tunnel experimental setup (a) side, (b) top and close view



**Figure 8.**  
Schematic of the setup for PE sensor mounted on the test plate

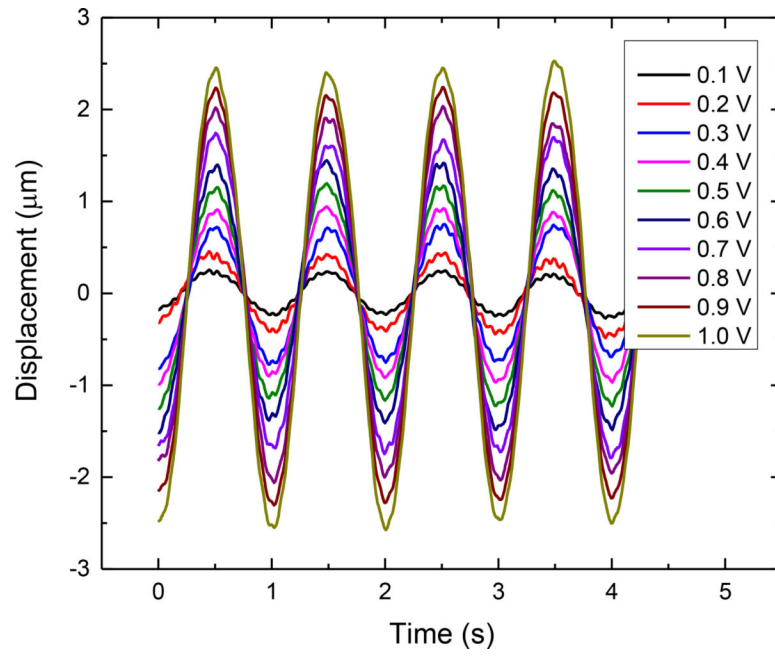


**Figure 9.**  
Cantilever beam with accelerated tip mass

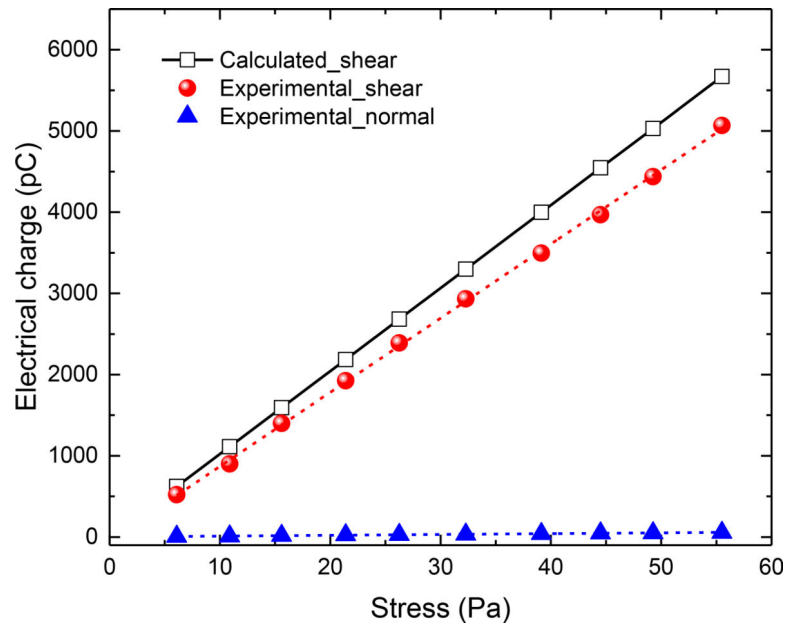


**Figure 10.**

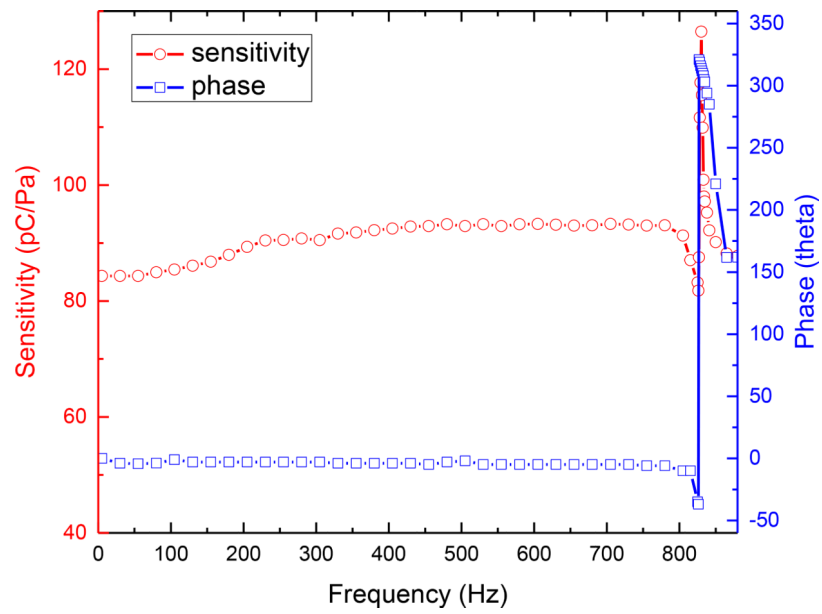
Experimental setup for (a) tripping the flow to turbulent boundary layer, (b) the Pitot tube measurement



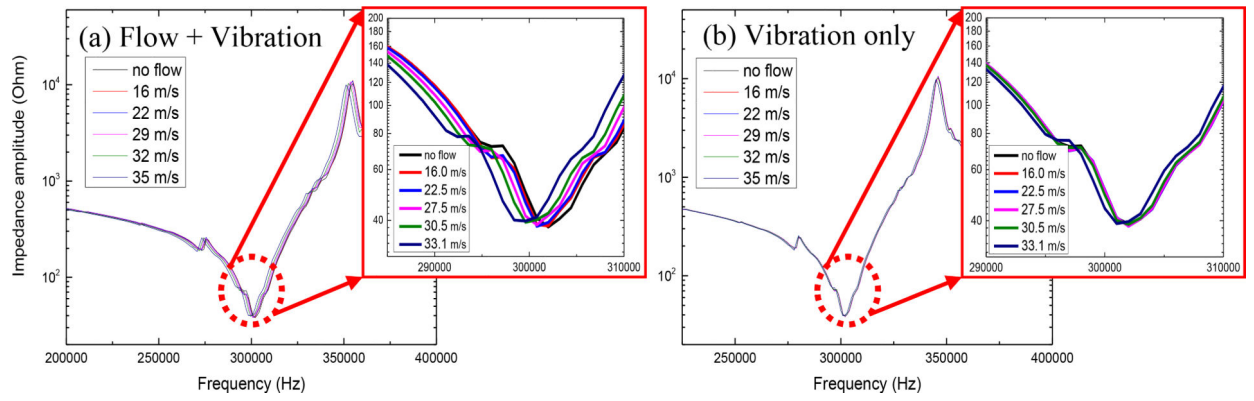
**Figure 11.**  
Peak-to-peak displacement of FE according to voltage amplitudes



**Figure 12.** Calculated (open black squares) and measured electrical charge output as a function of the shear (filled red spheres) and normal stress (filled blue triangles).



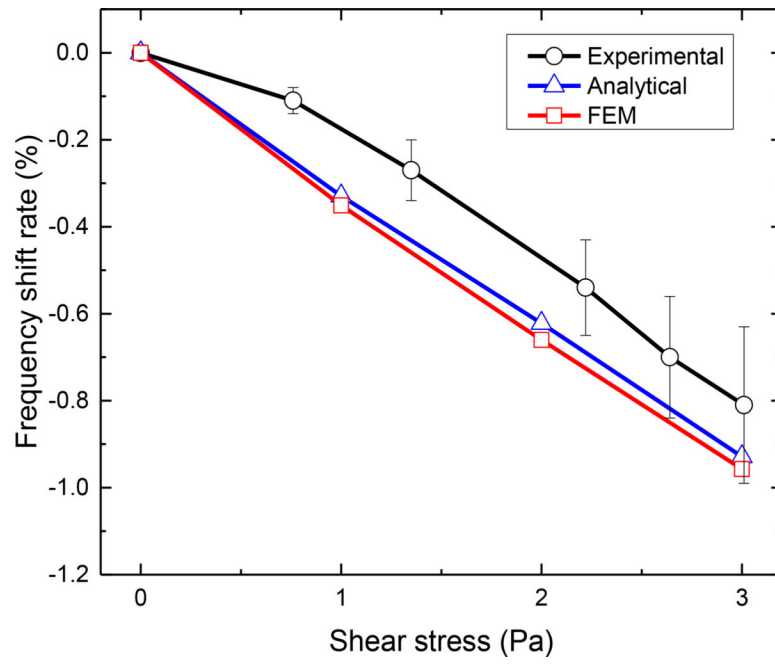
**Figure 13.**  
Usable frequency range of the sensor



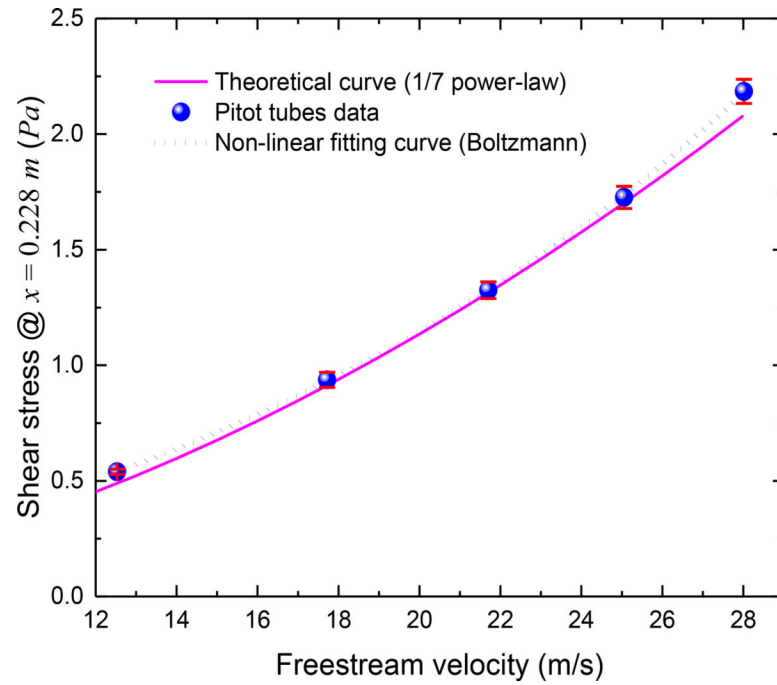
**Figure 14.**

Variations of frequency in the condition of (a) flow + vibration, (b) vibration only



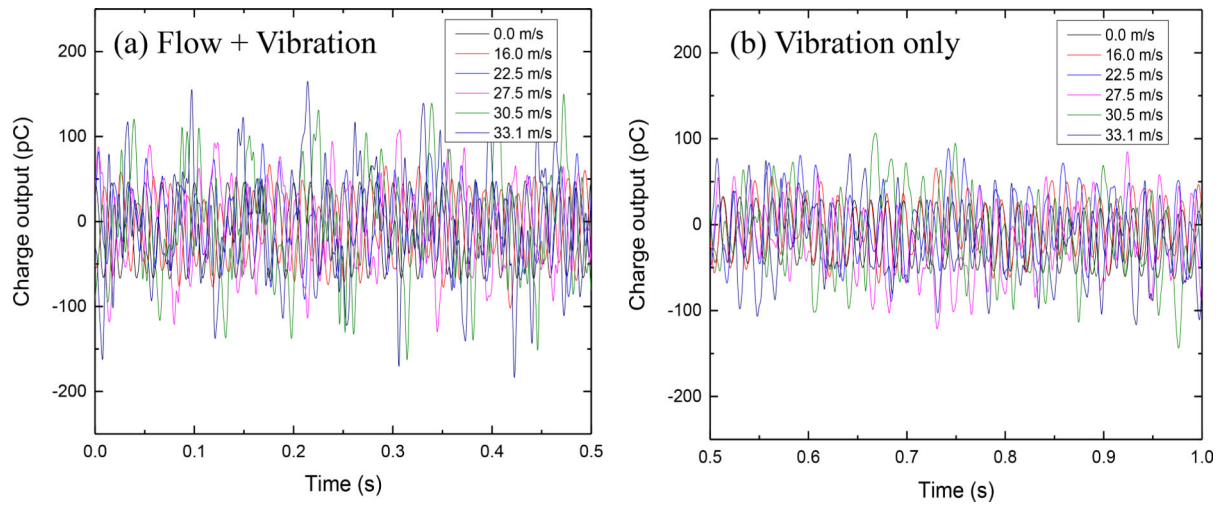


**Figure 15.**  
Comparison between modeled and experimental frequency shift rates



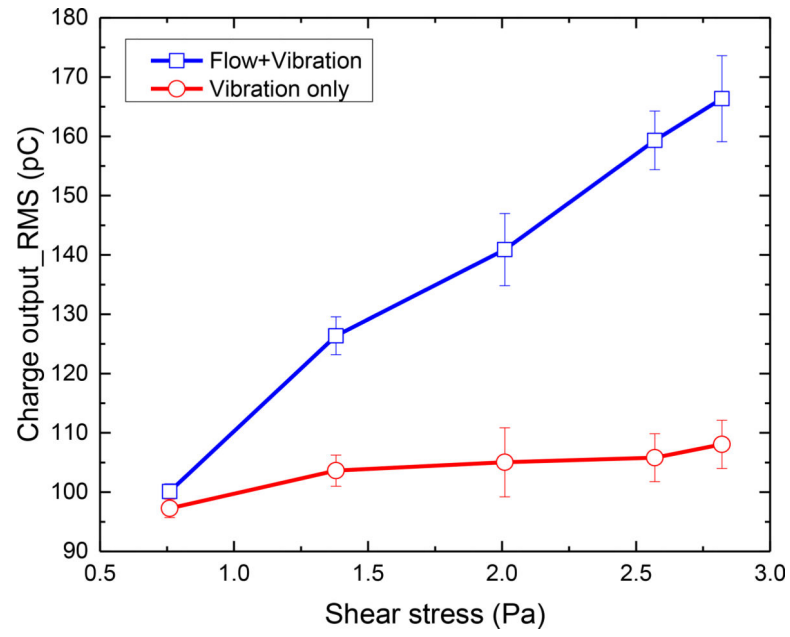
**Figure 16.**

Comparison in the shear stress between the Pitot tubes measurement and the theoretical analysis

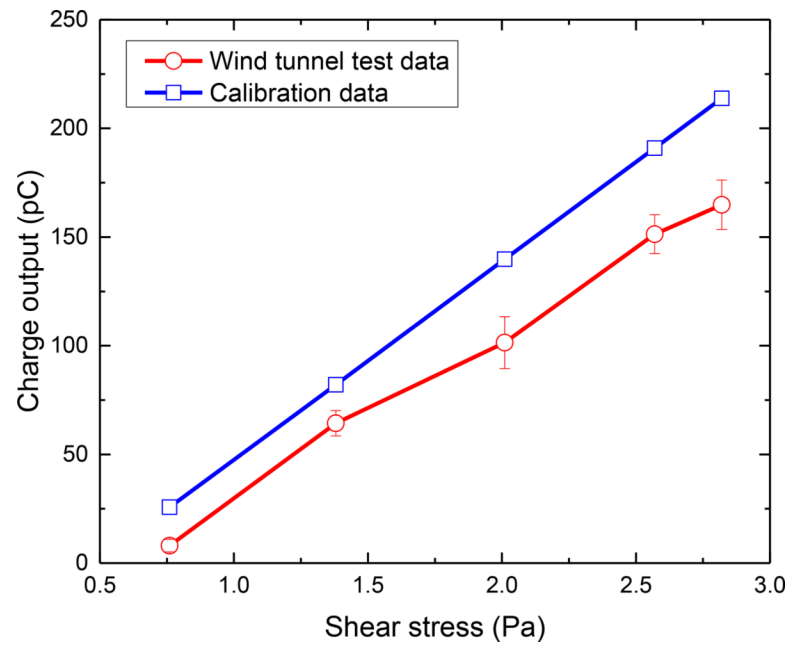


**Figure 17.**

Charge outputs for dynamic stress in the cases of (a) flow + vibration, (b) vibration only



**Figure 18.**  
RMS charge outputs between case #1 and #2



**Figure 19.**  
Comparison in charge outputs between test and calibration data